

GREENBLUM & BERNSTEIN, P.L.C.
Intellectual Property Causes
1950 Roland Clarke Place
Reston, VA 20191
(703) 716-1191

DFW

In re application of : Haujie CHEN, et al.

Attorney Docket No. P27157
Mail Stop Amendment

Serial No. : 10/689,506

Group Art Unit : 2813

Filed : October 20, 2003

Examiner : N. O. Berezny

For : HIGH PERFORMANCE STRESS-ENHANCED MOSFETs USING Si:C
AND SiGe EPITAXIAL SOURCE/DRAIN AND METHOD OF MANUFACTURE

Mail Stop Amendment

Commissioner for Patents
U.S. Patent and Trademark Office
Customer Service Window, Mail Stop Amendment
Randolph Building
401 Dulany Street
Alexandria, VA 22314

Sir:

Transmitted herewith is an **Supplemental Request for Reconsideration Under 37 C.F.R. § 1.111** in the above-captioned application.

☐ Small Entity Status of this application under 37 C.F.R. 1.9 and 1.27 has been established by a previously filed statement.

☐ A verified statement to establish small entity status under 37 C.F.R. 1.9 and 1.27 is enclosed.

☐ An Information Disclosure Statement, PTO Form 1449, and references cited.

☐ A Request for Extension of Time.

☒ No additional fee is required.

☒ Cover Letter Responsive to the Office Communication of November 1, 2005.

☒ Cover Letter to Submit Executed Rule 1.131 Declaration with attached Declaration Under 37 CFR 1.131 and Exhibit A (with 3 separate signature pages)

The fee has been calculated as shown below:

Claims After Amendment	No. Claims Previously Paid For	Present Extra	Small Entity		Other Than A Small Entity	
			Rate	Fee	Rate	Fee
Total Claims: 19	21	0	X25=	\$	x 50=	\$0.00
Indep. Claims: 2	3	0	X100=	\$	X200=	\$0.00
Multiple Dependent Claims Presented			+180=	\$	+360=	\$0.00
Extension Fees for ____ Month(s)				\$		\$0.00
Total:				\$	Total:	\$0.00

* If less than 20, write 20

** If less than 3, write 3

Please charge my Deposit Account No. 09-0458 in the amount of \$ ____.

N/A A Check in the amount of \$ ____ to cover the filing/extension fee(s) is included.

☒ The U.S. Patent and Trademark Office is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account No. 09-0458.

☒ Any additional filing fees required under 37 C.F.R. 1.16.

☒ Any patent application processing fees under 37 C.F.R. 1.17, including any required extension of time fees in any concurrent or future reply requiring a petition for extension of time for its timely submission (37 CFR 1.136)(a)(3).

Andrew M. Calderon
Reg. No. 38,093

P27157.A05

Serial No.: 10/689,506

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re patent application of:

Docket No. P27157

Haujie CHEN, *et al.*

Confirmation No. 4303

Appln. No. : 10/689,506

Group Art Unit: 2813

Filed : October 20, 2003

Examiner: N. O. Berezny

For : HIGH PERFORMANCE STRESS-ENHANCED MOSFETs USING Si:C
AND SiGe EPITAXIAL SOURCE/DRAIN AND METHOD OF
MANUFACTURE

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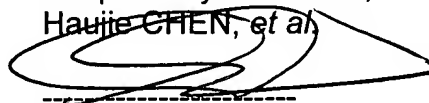
**COVER LETTER RESPONSIVE TO THE OFFICE COMMUNICATION OF
NOVEMBER 1, 2005**

Sir:

In response to the Office communication dated November 1, 2005, please replace the Rule. 1.111 Request for Reconsideration filed on August 31, 2005 with the Attached Rule 1.111 Supplemental Request for Reconsideration.

If extensions of time are necessary to prevent abandonment of this application, then such extensions of time are hereby petitioned under 37 C.F.R. § 1.136(a), and any fees required therefore (including fees for net addition of claims) are hereby authorized to be charged to Deposit Account No. 09-0458.

Respectfully submitted,
Haujie CHEN, *et al.*



Andrew M. Calderon
Reg. No. 38,093

November 24, 2005
GREENBLUM & BERNSTEIN, P.L.C.
1950 Roland Clarke Place
Reston, VA 20191
(703) 716-1191